IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	§	•
Hui-Jye Hshieh et al.	§	Group Art Unit: Unknown
	§	
Serial No. Unknown	§	
	§	Examiner: Unknown
Filed: Herewith	§	
	§	
For: A Method and System for Communicating	§	
Semiconductor Manufacturing Information To	§	
Customers	§	

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

The above-identified application is being after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

David M. O'Dell

Registration No. 42,044

4-12-04 HAYNES AND BOONE, LLP 901 Main Street, Suite 3100 Dallas, Texas 75202-3789 Telephone: 972-739-8635 Facsimile: 214-200-0853

File: 24061.123 R-72044.1

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 12, 2004.

Bonnie Boyle

Printed Name

In place of PTO-1449 PATENT AND TRADEMARK OFFICE Form

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)

Application Number Filing Date Herewith Applicant(s) Hui-Jye Hshieh

Art Unit Examiner Name

Attorney Docket Number

24061.123 (TSMC2003-0744)

-			U. S. PATENT DO	DCUMENTS
Examiner's Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document
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FOREIGN PATENT DOCUMENTS					
Examiner's:	Cite No:	Foreign Patent Document (Country Code - Number - Kind)	Publication Date	Patentee or Applicant of Cited Document	Translation

OTHER PRIOR ART			
Examiner's		Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume issue number(s), publisher, city/country where published:	
	AA	DENNYS SUNG-TING HSIEH et al., "B2B in TSMC Turnkey Services", 4 pgs.	
· ·			

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

SHEET

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